

Best Oral Presentation

Award

THIS CERTIFICATE IS PRESENTED TO

in ISAT-24



4-OB5

Sputtering Power and Si Substrate Dependence of SnO Thin Film
Fabrication

Yoshikazu Shin and Shinya Aikawa



Yasutada Imamura

Yasutada Imamura

Chair, ISAT-24 Organizing Committee

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